## What is claimed is:

- 1. An etch/strip apparatus integrated with cleaning equipment,
- 2 comprising:
- an etching line for etching and cleaning a substrate;
- a stripping line for stripping the substrate; and
- a cleaning line installed on the stripping line to clean and dry the
- 6 substrate.
  - 2. The apparatus as claimed in claim 1, further comprising:
  - an elevator for conveying the substrate from the stripping line to the cleaning line.
    - 3. The apparatus as claimed in claim 1, further comprising:
  - a transfer for moving the substrate from the etching line to the stripping line.
    - 4. The apparatus as claimed in claim 1, further comprising:
- a loader for feeding the substrate to the etching line; and
- a unloader for receiving the substrate from the cleaning line.
- 5. The apparatus as claimed in claim 1, wherein the etching line
- 2 includes:
- an etch module for etching the substrate from the loader; and
- a rinse module for cleaning the substrate fed from the etch module.

2

- 6. An integrated etch/strip/clean apparatus, comprising: 1
- an etching line for etching and cleaning a substrate; 2
- a stripping line for stripping said substrate; and 3
- a cleaning line integrated with said etching and stripping lines to 4
- clean and dry the substrate. 5
- 7. The apparatus of claim 6, wherein said cleaning line is installed on 1 said stripping line.
- 8. The apparatus of claim 6, wherein said etching line includes: 1
  - an etch module; and
    - a rinse module connected to said etch module.
    - 9. The apparatus of claim 6, further comprising:
  - a transfer module to transfer said substrate from said etching line to said stripping line.
- 10. The apparatus of claim 9, wherein said transfer module includes: 1
- a pipe shower. 2
- 11. The apparatus of claim 6, further comprising: 1
- an elevator to transfer said substrate from said stripping line to said 2
- cleaning line. 3
  - 12. The apparatus of claim 6, further comprising:

- a loader for loading the substrate to the etching line; and
- a unloader for unloading the substrate from the cleaning line.
- 1 13. The apparatus of claim 12, wherein said loader includes at least
- one of a conveyor and a robot.
- 14. The apparatus of claim 12, wherein said unloader includes at least
- one of a conveyor and a robot.